

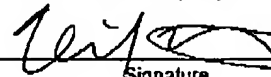
MAR 10 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 207.009-US)In the Application of: **Lutz et al.**Serial No: **10/777,326**Filed: **February 12, 2004**Title: **Integrated Getter Area for Wafer Level
Encapsulated Microelectromechanical
Systems**) Group Art Unit: **2813**) Examiner: **David S. Blum**) I hereby certify that this correspondence
) is being facsimile transmitted to the
) United States Patent and Trademark
) Office, Fax No. (571) 273-8300 onMarch 10, 2006

Date

Neil Sternberg

(name of person signing certificate)



Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**AMENDMENT AND REPLY OF MARCH 10, 2005**

Dear Sir:

Kindly amend the application as follows: